

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Aubrey Helms, Jr. et al.

Serial No.: **10/519,331**

Filed: **April 18, 2005**

For: **Method for Energy-Assisted Atomic
Layer Deposition and Removal**

Art Unit: **1792**

Examiner: **Stouffer, Kelly M.**

Confirmation No.: **9309**

Atty. Docket No.: **067538-5148-US01**

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This amendment is filed in response to the Office Action dated November 12, 2008. Accompanying this amendment is a petition of extension of time bringing the period of response to May 12, 2009. Please consider the following proposed amendments to the above-identified application and the remarks herein.

Please amend the application as follows.

A Listing of Claims begin on page **2** of this Amendment.

Remarks begin on page **5** of this Amendment.